Fabricating and printing chemiresistors based on monolayer-capped metal nanoparticles

Yana Milyutin^{®1,2}, Manal Abud-Hawa^{1,2}, Viki Kloper-Weidenfeld¹, Elias Mansour¹, Yoav Y. Broza¹, Gidi Shani¹ and Hossam Haick^{®1⊠}

Chemiresistors that are based on monolayer-capped metal nanoparticles (MCNPs) have been used in a wide variety of innovative sensing applications, including detection and monitoring of diagnostic markers in body fluids, explosive materials, environmental contaminations and food quality control. The sensing mechanism is based on reversible swelling or aggregation and/or changes in dielectric constant of the MCNPs. In this protocol, we describe a procedure for producing MCNP-based chemiresistive sensors that is reproducible from device to device and from batch to batch. The approach relies on three main steps: (i) controlled synthesis of gold MCNPs, (ii) fabrication of electrodes that are surrounded with a microbarrier ring to confine the deposited MCNP solution and (iii) a tailor-made drying process to enable evaporation of solvent residues from the MCNP sensing layer to prevent a coffee-ring effect. Application of this approach has been shown to produce devices with ±1.5% variance—a value consistent with the criterion for commercial sensors—as well as long shelf life and stability. Fabrication of chemical sensors based on dodecanethiol- or 2-ethylhexanethiol-capped MCNPs with this approach provides high sensitivity and accuracy in the detection of volatile organic compounds (e.g., octane and decane), toxic gaseous species (e.g., HCl and NH₃) in air and simulated mixtures of lung and gastric cancer from exhaled breath.

Introduction

Chemiresistors based on monolayer-capped metal nanoparticles (MCNPs) have been proven to determine and classify a number of diseases from exhaled breath, including lung cancer (LC)¹⁻³, colorectal cancer^{1,4}, head and neck cancer¹, ovarian cancer^{1,5,6}, bladder cancer¹, prostate cancer^{1,7}, kidney cancer¹, gastric cancer (GC)^{1,8-11}, Crohn's disease¹, ulcerative colitis^{1,12}, irritable bowel syndrome^{1,12}, idiopathic Parkinson^{1,13–15}, atypical parkinsonism^{1,14}, multiple sclerosis^{1,16,17}, pulmonary arterial hypertension^{1,18-20}, preeclampsia^{1,21}, chronic kidney disease^{22,23}, tuberculosis²⁴ and coronavirus disease 2019²⁵. The detection and discrimination between these diseases was possible because of a unique profile made of 15 volatile organic compounds (VOCs) that characterized each type. These VOCs are 2-ethylhexanol, 3-methylhexane, 5-ethyl-3-methyloctane, acetone, ethanol, ethyl acetate, ethylbenzene, isononane, isoprene, nonanal, styrene, toluene, decane, octane and undecane. Other studies have shown the effectiveness of MCNP-based sensors for environmental monitoring, i.e., indoor air quality monitoring²⁶, through the detection of benzene, xylene, ethylbenzene and toluene. MCNP-based sensors were applied in smart heating, ventilation and air conditioning control systems, human health monitoring (capnography), home monitoring kits and even growth condition monitoring in greenhouses. Sensors based on MCNPs offer advantages such as (sub-)ppb detection limits of VOCs, a wide dynamic range for detection, ambient room operation, tolerance for interruptive molecules, reasonable dimensions and low cost^{1,8,10,27-37}.

There are many reasons why it is advantageous to design assays around MCNPs, but there are three that are noteworthy here:^{8,25,30}

1 The first reason is the versatility in the composition of the MCNP itself, which relates to the presumed ability to synthesize, if not at will, then with much control, nearly any type of MCNP one wishes. Several studies have shown the ability to modify the MCNP's core type (i.e., Au, Ag, Pd and Pt) as well as the capping ligands (e.g., alkylthiols with C_3-C_{24} chains, ω -functionalized alkanethiolates, arenethiolate and (γ -mercaptopropyl)tri-methyloxysilane, dialkyl disulfides)¹⁻²⁵. For sensing applications, this feature implies that one can obtain MCNPs with a variety of

¹Department of Chemical Engineering and Russell Berrie Nanotechnology Institute, Technion–Israel Institute of Technology, Haifa, Israel. ²These authors contributed equally: Yana Milyutin, Manal Abud-Hawa. [⊠]e-mail: hhossam@technion.ac.il

synergetic combinations of chemical and physical functions, which, in turn, affect the sensitivity and selectivity of the sensors.

- 2 The second reason is the ability to vary the particles' size and shape and, therefore, the surface-tovolume ratio^{35,38}. For sensing applications, these features allow deliberate control over the domination of surface properties and, consequently, over the interaction 'quality' with the analyte molecules^{27,39}. Generally speaking, MCNPs with longer chain lengths present increasing responses and greater sensitivities to many VOCs and humidity levels.
- 3 The third reason is summarized in the ability to prepare films of MCNPs with controllable porous properties^{35,37}. This allows controllable mass transport (e.g., via diffusion), adsorption of analyte molecules within the empty pores, induced swelling of the MCNP films and changes in the permittivity of the medium between the MCNP cores.

MCNPs that rely on a gold nanoparticle core are considered an important candidate owing to their chemical inertness, environmentally benign nature and biocompatibility when functionalized with an appropriate ligand/group of ligands^{40,41}. The versatility in selection of the sensing layer composition (e.g., alkylthiols, dialkyl disulfides, DNA, proteins and alkanethiols) widens the range of the possible targets and application.

Overview for the production of MCNP-based chemiresistors

The production of MCNP-based chemiresistors starts with a synthesis of nanoparticles with specific organic ligands^{8,42}. Methodologically, several approaches has been proposed for the synthesis of MCNPs, including the two-phase⁴², one-phase⁴³ and water-soluble^{44,45} approaches. Synthesis is followed by the assembly of thin films made of MCNPs between adjacent microelectrodes³⁶. There are several deposition methods for microelectrodes, such as drop-casting⁴⁶, layer-by-layer deposition⁴⁷⁻⁴⁹, spin coating⁵⁰, spraying⁵¹ and others^{52,53} Nevertheless, the lack of reproducibility and repeatability and/or the complexity of the device fabrication or packaging of the devices have limited their application to laboratory and research purposes.

The problem of low reproducibility in these devices

The low reproducibility in both production and analytical results is due mainly to uneven evaporation of the MCNP-contained drying drop applied on the surface; as the liquid evaporates, the solid material remaining forms coffee rings and other irreproducible topologies⁵⁴. This phenomenon occurs despite strict control over printing volume, temperature, relative humidity and surrounding gas atmosphere^{55–57}. It is speculated that this coffee-ring phenomenon is caused by the 'Marangoni' effect, viz. a process in which the volatile compound evaporates faster near the fluid–substrate contact line^{55,58–62} In this mechanism, different attraction and repulsion forces create irregular movements of matter within the drying droplet, resulting in nonuniform thickness across the film and/or formation of 'coffee rings' in the matured chemiresistors^{55,63–65}.

Researchers have made many attempts to solve the irregularity problems of the MCNP-based films as well as the 'coffee ring' phenomenon^{62,66}. Nevertheless, the reported approaches have been shown to introduce other complications, as detailed below in the 'Comparison with other methods' section.

This protocol addresses this challenge by controlling the synthesis parameters and the use of a microbarrier ring around the electrodes to confine the formation of the MCNP-based sensing layer. The use of the microbarrier could dictate the shape of the drop and hinder the coffee-ring formation, yielding uniform chemiresistors, in terms of both structure and function⁸.

Comparison with other methods

To overcome the reproducibility challenges in the fabrication of MCNP-based chemiresistors, inkjet printing has been developed and implemented for the deposition of the MCNP solution on top of (micro-)electrodes^{49,65}. Typically, inkjet printing technology is based on thermal or piezoelectric heads that generate droplets in small (0.3 ± 0.02 nl) volumes of ink. This allows deposition of precise ink volumes in predefined locations on the substrate harboring the electrodes⁶⁷. Nevertheless, there is currently no inkjet printing technique that results in films that are sufficiently uniform for making chemiresistors reproducibly.

One of the solutions to solve the irregularities in the MCNP-based sensing layer relied on the addition of dipolar aprotic and a high-boiling-point solvent, such as 4% (vol/vol) *N*-methyl-2-pyrrolidone (NMP), to water-based MCNP solution. The formation of a specific contact angle between the printed emulsion and the solid surface influences the extent of the Marangoni

effect. This is the contact angle at which evaporation relative to the volume of liquid is maximum. In this way, as the contact line is rapidly deprived of solution, the slower evaporating component of the dual buffer will act in place of the MCNPs and concentrate itself near the contact line of the drying drop^{57,58,68,69}. This approach was found to reduce the pinning effect of the contact line with the substrate and, therefore, the coffee-ring effect⁶⁴. Yet, water-based solutions are less suitable for the production of functioning MCNP-based chemireisistors because of hydrophobic nature of the ligands. Furthermore, during printing, it is desired to have volatile solvents for fast evaporation.

Anyfantakis et al.⁷⁰ have shown that the addition of surfactant to the MCNP solution could lead to the transformation of typical coffee rings to fully homogeneous disk-shaped patterns. The effectiveness of the surfactant addition depends on its concentration as well as the nanoparticle/surfactant electrostatic charge. Hu et al.⁵⁵ have examined the effect of two different organic solvents with different vapor pressures on the quality of the formed MCNP-based films. They found this approach to partly mitigate some of the coffee-ring effects. The result is the formation of two (or more) opposing vortices that affect the in-time and in-space distribution of the MCNPs within the droplet⁵⁹. These two opposing vortices inhibit coffee-ring pinning^{55,71,72} and lower the contact angle hysteresis, facilitating lateral actuation of the drying drop.

Experimental design

The fabrication process of the MCNP-based sensors has four main steps: electrode fabrication, monolayer-capped gold nanoparticle (MCGNP) synthesis, inkjet nanoprinting and device conditioning (Fig. 1). For more details, please refer to the 'Procedure' section. For the sake of clear presentation, the presentation on the MCNPs will be focused on gold nanoparticles (MCGNPs). The fabrication of electrode arrays involves standard microfabrication methods. Figure 2 presents a flowchart including all steps involved in the development and optimization of the MCGNP-based sensors.

Each step can be optimized to find the conditions that result in the highest, most uniform response from the chemiresistors. In the first stage, synthesis optimization was carried out. Here the critical parameters were (i) the MCGNP synthesis temperature and (ii) the injection rate of the reducing agent (Box 1). In the next step, a microbarrier was fabricated and optimized, both in terms of material



Fig. 1 | Schematics of the chemiresistor fabrication. a, MCGNP synthesis by Brust method⁴². **b**, Inkjet printing above interdigital electrodes. **c**, MCGNP on the surface after drying.



Fig. 2 | Summary of the optimization scheme of the whole fabrication procedure. MCGNP synthesis, fabrication of electrodes, dispensing procedure, drying in vacuum oven and measuring the sensors' response after exposure to specific gaseous compounds. In this process, several parameters can be changed, including the MCGNP synthesis, the way the different chemistries and reducing agents are added into the synthesis process, and the structural design of the electrodes. VI, variability index.

Box 1 | Recommendations for optimizing the procedure for a different capping material

When exploring the possibility of using a new capping material, it is important to pay attention to, and to optimize, several parameters:

- 1 Synthesis temperature
- 2 Injection period of the NaBH₄ solution
- 3 Retaining the same interdigitated electrodes and microbarrier ring parameters as stated in the current protocol
- 4 Optimizing the printing parameters, mainly the concentration of the MCNP solution, droplet volume and the humidity and temperature of the printing environment
- 5 Optimizing the drying process, because it changes from one capping layer to another. The sensors with optimized drying time need to present the best sensing performance, upon exposure to VOCs, in terms of variability index (VI) and response

type and height, to enable most effective confinement of the MCGNP droplet. Then, for each chemistry type, the volume and concentration of the dispensed MCGNP solution as well as the conditioning parameters in a vacuum oven were evaluated. The duration of the conditioning step is critical. This is because insufficient drying would cause a drift in the baseline resistance because of evaporation of solvent residues captured within the film. On the other hand, overdrying could decrease the content of the organic ligands capping the nanoparticles⁷³. This brings the nanoparticles in the film closer to each other and reduces in the overall thickness of the film. All these changes can lead to a substantial decrease in the baseline resistance and a loss of chemical sensitivity⁷³. After conditioning, experiments were done to see how the product responded to exposure to specific VOCs. The parameters that resulted in the lowest VI are selected for use in the chosen application.

Optimizing MCGNP synthesis

The synthesis of the MCGNP was achieved by the two-phase Brust method⁴². For the sake of clear presentation, the current protocol will be focused on two representative ligands as organic capping layers: dodecanethiol and 2-ethylhexanethiol. The synthesis process starts with the transfer of AuCl₄⁻ from an aqueous HAuCl₄· 3H₂O solution to a toluene layer using a phase-transfer reagent, tetra-octylammonium bromide. Excess thiols are added to the isolated toluene solution, and an aqueous solution of NaBH₄ reducing agent is added in large excess. The reaction occurs under vigorous stirring at room temperature (RT, 22–25 °C) for >3 h, producing a dark-brown solution of the thiol-capped gold nanoparticles. The solvent is removed with a rotary evaporator, and the MCGNPs are washed many times in ethanol and toluene³⁶.

To precisely control the MCGNPs' core size and distribution, which would in turn affect the sensitivity and stability of the formed sensing film, two parameters were optimized: (i) the

temperature of the synthesis (-20 °C, +4 °C and +30 °C) and (ii) the injection period of the NaBH₄ solution (1 s, 2 min, 3 min and 4 min). For the two represented chemistries, the best performance of sensors was achieved when the synthesis of dodecanethiol took place at 30 ± 1 °C solution temperature and in a 1-s injection period for NaBH₄ and at 4 ± 1 °C and in a 30 ± 0.5 -s NaBH₄ injection period for 2-ethylhexanethiol. More details on the synthesis are outlined in the procedure section below. Transmission electron microscopy (TEM) analysis showed these conditions to produce, respectively, gold nanoparticles with core diameter of 2.4 ± 0.7 nm and 2.2 ± 0.4 nm in the case of dodecanethiol and 2-ethylhexanethiol capping layers (Extended Data Fig. 3).

Preparation of electrodes

In parallel to the synthesis process, electrodes were fabricated on a silicon wafer with 1 μ m thermal silicon oxide (SiO₂) by two photolithography steps: (i) metal evaporation and (ii) polymer barrier (SU-8) deposition. The interdigitated electrodes are based on titanium (adhesive layer) and platinum. The external diameter of the circular electrode area is 1 mm, and the gap between the electrodes is 10 μ m (Supplementary Data 1 and Supplementary Software).

Fabrication and characterization of a microbarrier ring

In this part of the method development, it is important to be able to measure the thickness, crosssection and chemical composition at different places in the dried nanoparticle layer. We do so by atomic force microscopy and/or by scanning electron microscopy (SEM).

Optimization of conditioning without the microbarrier ring. An overall volume of 20 ± 0.3 nl MCGNP solution was deposited via successive injection of 0.3 ± 0.02 nl droplets in the middle of the microelectrodes (1 mm external diameter of the circular electrode and 10 µm gap between the electrodes) using the sciFLEXARRAYER S3 dispenser system (Supplementary Data 1 and Supplementary Software). This volume was selected after an optimization process to assure no solution spillage from the ring. Following a stabilization process⁷⁴, it was found that the best performance and longest stability could be achieved when the MCGNP layers are conditioned in a vacuum oven at 55 °C for 72 h in the case of dodecanethiol capping ligand (5 mg/ml) and at 55 °C for 48 h in the case of 2-ethylhexanethiol capping ligand (30 mg/ml). Extended Data Fig. 2 shows the topology of the drying droplets producing the sensing layers. As seen in the figure, the layers exhibited a 'coffee-ring' topology with varied thickness from 0.3 to 2.5 µm (Extended Data Fig. 2c).

X-ray photoelectron spectroscopy (XPS) analysis, carried out with a Versaprobe III (Physical Electronics) having an AlKa monochromatic X-ray source (hv = 1486.6 eV; 15 kV) with 100 µm diameter, has shown that the different thicknesses of the rings within this topology exhibit different chemical and composition features^{75,76}. For example, the relative concentration of O1s peak, which indicates oxidation process, was found to be higher (20.83%) in the thick area (2.5 µm) than in the (0.3 µm) thin area (3.72%) (Fig. 4d and Supplementary Fig. 16). This difference indicates that thin and uniform layers are desirable for the production of stable sensors.

As a way to achieve reproducible and uniform film with a low percentage of topological irregularities, a microbarrier ring around the electrodes was developed to confine the deposited MCGNP solution during the evaporation process (Fig. 3a). The approach, which adds only a single step to the chemiresistor fabrication process, can be used to produce microbarrier rings from a wide variety of insulating materials, such as SiO₂, epoxy or photosensitive polymer (SU-8). Figure 3b,c depicts the production process of the microbarriers from SU-8 and SiO₂, respectively.

The efficacy of MCGNP deposition highly depends on the interface between the MCGNP solution and the inner side of the microbarrier ring. We thought that the most important parameter in determining the quality of this interface might be the wetting properties of the interacting surface. This is because the contact line is minimized with the lower-wettability surface during the deposition of the MCNP solution, thus holding the solution within the walls of the ring. The most commonly used method for analyzing surface wetting is to determine the contact angle between the surface and a droplet of the liquid of interest. The contact angles between water droplet with SU-8 and SiO₂ were examined using an optical goniometer. As seen in Extended Data Fig. 3a, pristine SU-8 exhibited a high contact angle to water ($\theta = 90^{\circ}$ contact angle to $\theta = 35^{\circ}$ (Extended Data Fig. 3b). On the other hand, wetting analysis on SiO₂ shows high wetting ($\theta = 180^{\circ}$) (Extended Data Fig. 3c), indicating high hydrophilicity. To gain more insight into the MCGNP-substrate interface, the microbarrier structure between the two



Fig. 3 | Fabrication process of MCGNP-based sensing chips. a-c, Schematic depiction of chips with eight MCGNP-based sensors and a resistor for temperature control, fabrication process of SU-8-made microbarrier (see Supplementary Data 1) (b) and SiO₂-made microbarrier (c). d, Microscopic images of sensors based on dodecanethiol-capped gold nanoparticles with and without microbarrier. The dark edges on the outer side of the electrodes are the ring-like barriers.

materials was examined by SEM. Extended Data Fig. 4a,b shows that the edge of the microbarrier made from SiO_2 is rough and uneven, probably due to the lift-off process. Conversely, the edge shape of the microbarrier made of SU-8 polymer is straight and vertical to the underlying substrate (Extended Data Fig. 4c,d). Overall, these characterizations indicate that microbarriers made of SU-8 are advantageous, mainly because of their superior ability to hold the MCGNP solution, thus preventing any 'spillover' and/or migration of the deposited MCGNP droplet.

To evaluate the effect of the microbarrier on the sensing performance, several sets of MCNGP-based chemiresistors were prepared: without microbarriers and with SiO₂ or SU-8 microbarriers. Each set included several chips, each with eight electrodes, viz. sensors. Each electrode in the aforementioned set was injected with 40 nl or 20 nl droplet volume (Supplementary Information). Figure 4a,d shows light-microscopy images of chemiresistors that were prepared, respectively, by injection of 40 nl 2-ethylhexanthiol-capped and dodecanethiol-capped gold nanoparticles without use of any microbarrier. As seen in the figure, the deposited layers were nonuniform with flow outside the external border of the electrodes. The addition of a SiO₂ microbarrier (Fig. 4b,e) partially restricted the flow of the printed emulsion at the time the existence of the SU-8 microbarrier (Fig. 4c,f) held the MCGNP drop strictly within its borders and unified the morphology of the resulting sensing layers. To evaluate the effect of the MCGNP film morphology on the sensing response, each set of sensors was exposed to escalating doses of octane. Each exposure dose included 5 s entrance of the specific concentration of simulation gas (i.e., n-octane), 5 min exposure to the simulation gas (closed chamber, no valves open) and 5 min vacuum. For more details, please refer to Steps 72–81, in the 'Measuring the sensors' response' section of the Procedure.



Fig. 4 | Optical microscopy images and sensing response signals to various octane concentrations of chemiresistors. a-c, The chemiresistors were prepared by depositing 40 nl 2-ethylhexanethiol-capped gold nanoparticles (20 mg/ml) on electrodes without a microbarrier (**a**), with a SiO₂ microbarrier (**b**) and with a SU-8 microbarrier (**c**). **d-f**, For comparison, similar image formats are presented for chemiresistors prepared by deposition of 40 nl dodecanthiol-capped gold nanoparticles (5 mg/ml) on electrodes: without microbarrier (**d**); with SiO₂ microbarrier (**e**); and with SU-8 microbarrier (**f**). Sensing responses to octane were achieved after drying in a vacuum oven at 55 °C for 48 h in the case of 2-ethylhexanethiol-capped gold nanoparticles.

As seen in Fig. 4, the addition of the microbarrier rings increased the uniformity of the sensing responses of the fabricated sensors. Indeed, the VIs for 2-ethylhexanthiol changed from 7.8% in the case of the bare electrodes (i.e., without microbarrier) to 5.6% for the SiO_2 microbarrier, and to 1.6% in for the microbarrier made of SU-8. Consistently, the VI for dodecanethiol-capped gold nanoparticles decreased from 12.6% of the bare electrodes to 2.5% for the microbarrier made from SU-8 polymer (Fig. 4c,f).

Optimization of the microbarrier height

Evaporation of solution at small scales depends heavily on the characteristics of the thin surface-tension-driven interface effects. Therefore, the effect of the microbarrier height on the evaporation of MCGNP solution droplet as well as on the obtained quality of the sensing layer was examined (Extended Data Fig. 5). Optimizing the physical parameters of the ring for different chemistries is carried out by looking for the lowest possible VI while keeping the amplitude as high as possible. Since there is a trade-off between VI and magnitude of response, they are presented side by side in Extended Data Fig. 5. (Note that the amplitude is $\Delta R/R_b$ and is denoted as percentage.)

In this context, different microbarrier heights (2.4, 5.5 and 17 µm) were evaluated. Figure 4 and Extended Data Fig. 6a show that sensors prepared from 40 nl solution of 2-ethylhexanethiol-capped gold nanoparticle in 2.4 µm and 5.5 µm microbarrier heights exhibit good VIs (1.3% and 1.6%, respectively). On the other hand, the microbarrier height affected the sensing response substantially, as expressed in its amplitude. As seen in Extended Data Fig. 6b, the response amplitude of the 2.4 µm microbarrier height was 0.31%, whereas the response amplitude in the case of the 5.5 µm microbarrier height was 0.77%. To determine the source of these differences, complementary analysis was carried out. Figure 10c shows that dodecanethiol-capped gold nanoparticles printed in 2.4 µm and 5.5 µm microbarrier heights had similar VIs (2.5% and 2.6%, respectively). However, each barrier height worked best with a different printed volume. A droplet volume of 40 nl worked best for a 2.5 µm barrier, and a droplet of 120 nl worked best for a 5.5 µm barrier. Interestingly, the amplitude (Extended Data Fig. 6d) showed a trade-off between the two microbarrier heights. If 40 nl was printed on a 2.5 µm ring, an amplitude of 0.41% could be reached; however, when printing 120 nl on a 5.5 µm ring, an amplitude of 1.14% could be reached. Overall, these results indicate that the coffee ring on the surface can be prevented and the best sensing performance can be achieved when the height of dropped solution is strictly the same as the barrier height.

Stability and storage conditions

Storage conditions. Different storage conditions can affect the configuration of the MCGNP films as well as the stability and the amplitude of the sensing signals. To identify the most suitable conditions to store the sensors for a long time, storage conditions were evaluated in different conditions for a period of 9 months. Sensors were stored and sealed in aluminum-laminate pouches using an aluminum bag sealer (MeC Impulse Sealer) and a needle (BD Microlance 3) in three conditions:

(i) vacuum at 300 mbar; (ii) nitrogen at 99.9998% purity and (iii) room air at 18 °C and 40 \pm 2% relative humidity.

The evaluation of the stability was carried out upon exposure to 272 ppb of 1-methylnaphthalene in nitrogen for three repetitions at different time points during the 9-month period. Each repetition included a cycle of 5 s for entrance of the simulation gas (i.e., 1-methylnaphthalene), 5 min of exposure to the simulation gas (closed chamber, no valves open) and 5 min of vacuum. This cycle is repeated three times with the same concentration and conditions. For the sensing response analysis, $\Delta R_{end}/R_b$ (where ΔR is the difference between the resistance before and at the end of the exposure to 1-methylnaphthalene and R_b is the baseline resistance) was used.

Extended Data Fig. 7 summarizes the change in the $\Delta R_{end}/R_b$ during the various storage conditions of 24 dodecanethiol-capped gold nanoparticle sensors as a representative example. As seen in the figure, the change in the room air storage condition (35%) after a 9-month period was significantly larger than that in the vacuum and nitrogen conditions (19% and 17%, respectively). Moreover, the variances between the sensors' reading under room air and nitrogen storage, as can be seen by the height of the boxes, were larger than those in vacuum condition. These results can be understood intuitively, as the presence of compounds in the room air condition (for example oxygen and humidity) can have negative effects on the interactions of the ligands of the capped gold nanoparticles as well as their organization. Storage in nitrogen showed higher variances than in vacuum, making it the best candidate for storing capped gold-nanoparticle sensors. Nitrogen can present a second option, or a combination of both, if high vacuum is not available. If nitrogen is chosen, it is important to ensure that the purity is high, reaching at least 99.999% as has been used in this experiment.

Lifetime. The lifetime of a sensor array is most commonly defined as the time to the first sensor node failure. To examine this aspect in the context of MCGNP-based sensors, a series of repetitive tests was carried out. It consisted of 45 measurement cycles per day (10 min each) \times 5 d/week \times 9 weeks, bringing it to a total of 2,025 measurements. On each measuring day, the sensors were taken out of the desiccator and placed in the analysis chamber. During this short transfer period, the sensors were exposed to air in the laboratory (\sim 18 °C, 40% relative humidity), after which they were examined under successive cycles of 272 ppb exposure to 1-methylnaphthalene. Figure 5b presents the flowchart of the measurement in the evaluation process of the lifetime aspect of the sensors. Figure 5c,d shows the $\Delta R_{end}/R_b$ values of the sensors. As seen in the figure, the sensors have high responsivity on the first 25 d of exposure, i.e., a total of ~1,500 cycles. After this period (on day 26), the noise becomes very high, and therefore, the sensor has to be exchanged.

Chemical stability. To check the influence of exposure to hazardous substances, the MCGNP sensors were exposed to NH_3 and HCl. The exposure of the devices caused no major direct changes in the absolute values of the base resistance of the MCGNP sensors (Fig. 6a). Figure 6b–e visualizes the exposure effect on the response of the MCGNP sensors. While for the 2-ethylhexanethiol-capped gold nanoparticle sensor the response to acetaldehyde is slightly increased after exposure to NH_3 (Fig. 6c), the 2-ethylhexanethiol-capped gold nanoparticle sensor exhibited opposite behavior, showing a decreased response after NH_3 exposure (Fig. 6b). After exposure to HCl, the response of the 2-ethylhexanethiol-capped gold nanoparticle sensor was not significantly changed (Fig. 6e), while the dodecanethiol-capped gold nanoparticle sensor showed a slightly increased response (Fig. 6d).

Application of the method

Recognition of chemicals can be achieved by selective detection of (pre-)identified chemicals in the presence of an interfering gaseous species or background, using a highly selective receptor designed especially for the targeted VOC^{29,30,34,78}. This group of sensors requires laborious identification of the targeted VOC in the presence of interfering background as well as synthesis of a highly selective nanomaterial for each VOC of interest⁷⁹. There are several examples of selective sensing of chemicals, including detection of acetone^{74,80–82}, alkythiols^{37,51,83}, alkylamines⁸⁴ para-thiophenols⁸⁵, carbox-ylates⁸⁶ and others^{30,87–91}. Still, selective MCNP-based sensors are programmed to detect specific individual targets, thus hindering the extension for detecting complicated (VOC) mixtures. An additional limitation stems from the need to synthesize separate, highly selective nanomaterials for each VOC to be detected.

An emerging strategy that is complementary to the selective sensing approach is cross-reactive (i.e., semiselective) sensor arrays in combination with pattern recognition⁹², which are sensitive to a



Fig. 5 | Lifetime characterization of dodecanethiol-capped and 2-ethylhexanethiol-caped gold nanoparticle sensors. a, Typical sensor response to increasing concentrations of VOC. **b**, Flowchart of the measurement steps. **c**,**d**, $\Delta R_{end}/R_{b}$ response of dodecanethiol-capped (**c**), and 2-ethylthexanethiol-capped (**d**) gold nanoparticle sensors upon exposure to 272 ppb 1-methylnaphthalene.

broad spectrum of chemical patterns. In contrast to the selective sensing method, this approach is more suitable for rapid diagnostic methods in which evaluation of a chemical compendium is qualitative and semiquantitative^{91,93,94}, while achieving selectivity through pattern recognition^{93,95,96}.

To demonstrate the efficacy of the fabricated chemiresistors toward detection of VOCs, dodecanethiol- and 2-ethylhexanethiol-capped gold nanoparticle-based sensors were individually exposed to four VOCs (2-ethylhexane, isopropyl alcohol (IPA), octane and trimethylbenzene) at a concentration of 15 ppm. Principal component analysis (PCA)⁹³ was then used to analyze the obtained signals. PCA is a statistical method to effectively reduce the multidimensional data space to its main components to allow convenient visualization of the differentiation ability of the sensor array. PCA determines the linear combinations of the sensor values so that the maximum variance between all data points can be obtained in mutually orthogonal dimensions. As shown in Fig. 14a, the first and second principal components for each VOC are drawn; the two types of sensors have different responses to the different VOCs. Figure 7b shows the PCA analysis; the results yield well-defined clusters with no overlap between the four VOCs.

As an additional demonstration, the performance of dodecanethiol- and 2-ethylhexanethiolcapped gold nanoparticle sensors were evaluated in their ability to distinguish between simulatedbreath biomarkers between LC (n = 170; 118 ppm average concentration of decane) and the



Fig. 6 | Chemical stability tests. a, Base resistance of MCGNP-based chemiresistors before and after exposure to NH_3 and HCl. **b**,**c**, Sensing response of dodecanethiol-capped (**b**) and 2-ethylhexanethiol-capped (**c**) gold nanoparticle sensors to 500 ppb acetaldehyde before and after exposure to NH_3 . **d**,**e**, Sensing response of dodecanethiol-capped (**d**) and 2-ethylhexanethiol-capped (**e**) gold nanoparticle sensors to 500 ppb acetaldehyde before and after exposure to NH_3 .

equivalent healthy controls (HLC; n = 168; 0.5 ppm average concentration of decane) (Fig. 8a). Additional evaluation was carried out in the ability to distinguish between GC (n = 168; 117 ppm average concentration of 2-butanone) and the equivalent healthy controls (HGC; n = 168; 7 ppm



Fig. 7 | Utility of the optimized MCGNP-based chemiresistors in detection and differentiation between various VOCs. a, Response of dodecanethiolcapped and 2-ethylhexanethiol-capped gold nanoparticle chemiresistors to 15 ppm 2-ethylhexane (2EH), IPA, octane and trimethylbenzene (TMB). b, PCA of the produced exposure datasets.



Fig. 8 | DFA plots of first canonial value (y axis) that were calculated from the multidimensional data output. a,b, The outputs were obtained from: simulated breath biomarkers between LC (n = 170; 118 ppm average concentration of decane) and the equivalent healthy controls (HLC; n = 168; 0.5 ppm average concentration of decane) (**a**); and simulated breath biomarkers between GC (n = 168; 117 ppm average concentration of 2-butanone) and the equivalent healthy controls (HGC; n = 168; 7 ppm average concentration of butanone) (**b**). Note: DFA is a supervised classification method. Using a linear combination of the input variables, DFA finds new orthogonal axes (canonical values) to minimize the variance within each given class and maximize variance between classes.

average concentration of 2-butanone) (Fig. 8b). The concentration of the simulated-breath biomarkers was determined based on gas-chromatography-mass-spectrometry (GC-MS) analysis of real breath samples of LC, HLC, GC and HGC. The letter 'n' stands for the number of people whose breath samples were analyzed to extract the average concentration of the disease biomarker. Exposure to the breath samples or the calibration compounds resulted in rapid and reversible changes of the sensors' electrical resistance. Breath components were identified from the time-dependent resistance response of each sensor. Each sensor responded to all (or to a certain subset) of the VOCs found in the exhaled breath samples. Breath patterns were obtained from the collective response of the sensors by applying discriminant factor analysis (DFA). The DFA output variables constitute mutually orthogonal dimensions. We divided the dataset of each analysis into training (70% samples) and test sets (30% samples). Leave-one-out cross-validation was used to calculate the classification success in terms of the numbers of true positive, true negative, false positive and false negative predictions. Given k measurements, the model was computed using k - 1 training vectors. Receiving operating characteristic analysis was used to test the performance of the training set data and to calculate the cutoff values. For the LC versus HLC comparison, the results exhibited 100% accuracy in the training phase, 100% accuracy in the validation phase and 100% in the blind analysis phase. For the GC versus HGC comparison, the results exhibited 97.9% accuracy in the training phase, 100% accuracy in the validation phase and 100% in the blind analysis phase.

Challenges and opportunities

In the current protocol, we eliminate the uneven drying related to formation of the coffee rings by adding a physical microbarrier around the drying drop. The addition of the microbarrier ring is, therefore, speculated to eliminate the formation of a typical contact angle and, in this way, allow a more even evaporation across the drying drop. Nevertheless, if this speculation holds true, the volume of the drop needs to be proportional to the height of the microbarrier ring. Interestingly, our results are consistent with this hypothesis, showing that for each specific organic modification of the MCGNP solution, a specific volume and microbarrier height calibration is needed.

In the functional realm, avoiding the formation of coffee rings translates to a more consistent response of the resulting chemiresistor devices (Fig. 7). Indeed, some device-to-device differences will inevitably remain dependent on the precision of the analysis; yet, a marked reduction in the level of this variability is evident after addition of this microbarrier ring. This observation is consistent throughout many different modifications and seems to be independent of the gas stimuli to which the sensors respond. The presence of the microbarrier ring also holds the drying drop together and physically prevents slideover and spillover. By dictating the precise location and restricting the widening of the drying drop, it also forces aspects of its surface topology as a cured device. The capacity of this restriction may be dependent on the hydrophobicity of the material of which the microbarrier is made. Both these aspects described above contribute to the enhanced functional reproducibility of the printed devices. It is therefore up to future research to specifically analyze the different forces that are altered by the addition of the microbarrier ring. Whatever the mechanism is, this simple and practical addition has made an immense contribution to fabricating the reproducible device and will thus be used in any further investigations we conduct in the future.

One of the challenges that could affect the repeatability in the device fabrication is the variation in controlling the synthesis conditions (e.g., temperature and reducing agent injection rate). It is important to maintain the same temperature and stirring rate during synthesis. In some syntheses, the MCGNPs do not dissolve directly with ethanol in the precipitation step, and therefore a methanol solution can be used. Another possible challenge is the control of humidity during inkjet printing. Variances in humidity could affect the uniformity of the drops during and after printing, which could cause problems in fabrication and mass production of chemiresistors. After inkjet printing, the process for drying the devices in a vacuum oven needs to be optimized. The optimized time is determined by evaluating the sensor performance upon exposure to VOCs and analyzing the VI and response behavior.

Materials

Reagents

- Silicon wafer, 4 in diameter, ~500 μ m thickness, one side polished, type/orientation NP<100>, PB<100>, resistivity 1–10 Ω -cm, 1000 nm thermal SiO₂ (NOVA Electronic Materials, item. no. 7375-OX)
- Photoresist SU-8 2002 (Microchem, CAS no. T111029) **!CAUTION** Wear safety glasses, gloves and protective clothing when handling this material. Adequate ventilation is highly recommended to avoid breathing in the vapors or mist.
- Photoresist developer (PGMEA; Microchem, CAS no. 108-65-6) **! CAUTION** Wear safety glasses, gloves and protective clothing when handling this material. Adequate ventilation is highly recommended to avoid breathing in the vapors or mist. Keep away from oxidants, sparks and open flames.
- Image Reversal Photoresist AZ-5214E (MicroChemicals, CAS no. 220986) **!CAUTION** Wear safety glasses, gloves and protective clothing when handling this material. Adequate ventilation is highly recommended to avoid breathing in the vapors or mist. Keep away from oxidants, sparks and open flames.
- Photoresist AZ-4233 (MicroChemicals, CAS no. 220986) **!CAUTION** Wear safety glasses, gloves and protective clothing when handling this material. Adequate ventilation is highly recommended to avoid breathing in the vapors or mist. Keep away from oxidants, sparks and open flames.
- Tetramethylammonium hydroxide (TMAH; for AZ photoresist developing, 10% (wt/wt) solution in water; Sigma, CAS no. 75-59-2)

- 1-Methyl-2-pyrrolidinone (NMP; for PDMS etching, 99+% A.C.S. reagent; Sigma, CAS no. 443778) **!CAUTION** Wear safety glasses and impervious clothing. Handle the compound with gloves. This chemical can cause skin and eye irritation.
- IPA (Gadot, CAS no. 67-63-0) !CAUTION Flammable.
- Acetone (Gadot, CAS no. 67-64-1) ! CAUTION Flammable.
- Sodium borohydride ReagentPlus, 99% BH₄•Na (Sigma, CAS no. 16940662)
- Tetraoctylammonium bromide 98% (TOAB) [CH₃(CH₂)₇]₄N Br (Sigma, CAS no. 14866332)
- Gold(III) chloride trihydrate ≥99.9% trace metals basis HAuCl4•3H2O (Sigma, CAS no. 16961254)
- Dodecanethiol ≥98% CH₃(CH₂)₁₁SH (Sigma, CAS no. 112550)
- 2-Ethylhexanethiol \geq 97% C₈H₁₈S (Sigma, CAS no. 7341-17-5)
- Deionized destilled water (DDW; Milli-Q, cat. no. Z00QSV0WW)
- Ethanol (absolute) ≥99.8% (BioLab, cat. no. 64175)
- Toluene C_7H_8 [Isomers] 99.8% (BioLab, cat. no. 108883) **! CAUTION** Flammable. Irritant to eye, skin and respiratory tract. Wear gloves and goggles, and use a properly ventilated chemical hood when handling.
- N-octane (Sigma, CAS no. 111-65-9)
- 2-Ethylhexanol (Sigma, CAS no. 104-76-7) **! CAUTION** Flammable and unstable explosives. Wear gloves and goggles and use a properly ventilated chemical hood when handling.
- Dimethyl sulfide (Sigma, CAS no. 75-18-3) ! CAUTION Flammable.

Equipment

Clean room equipment

- Hot plate (Prazitherm, Harry Gestigkeit, cat. no. 16271017)
- Headway Resist Spinner (Laurell Technologies; model RWM32)
- Contact mask aligner (Karl Suss MicroTech; model MA-6)
- Soda-lime photolithography masks (substrate size 5':127.0 ×127.0 mm; Technion)—two masks: one for electrode array photolithography, the other for creating the microbarrier using photosensitive polymer SU-8 (Supplementary Data 1 and Supplementary Software)
- Optical microscope (Olympus Optical, model BX60F-3)
- Plasma descumming system (Axis HF-8 Multimode)
- E-beam evaporation system (Evatec, cat. no. BAK-501)
- Ultrasonic Cleaning Bath, S30 (Elmasonic)
- Dicer machine DAD 3350 (Disco; serial no. KB4725), dicing tape 80 μm
- Tweezers (Rubis, 2A-SA, cat. no. 2-8028-09; 2A Axal, cat. no. 2-5149-09; F Axal, cat. no. 2-5149-20)

Wet lab equipment

- Desiccator vacuum, lab companion cabine (Scienceware, cat. no. BAF424004021-1EA)
- Dishes, crystallizing, 140 × 75 mm (Pyrex; Technion, cat. no. 110000705)
- Petri dishes, complete 150 × 30 mm (Pyrex; Technion, cat. no. 110000757)
- Round-bottomed flask (Duran, cat. no.21741440)
- Digital pipettes, (Gilson NEO, P100 cat. no. F123615, P200 cat. no. F123601, P1000 cat. no. F123602)
- Pipette tips, Yellow 20-200 µl (Corning, cat. no. 4866)
- Separatory funnels (Kemtech America Synthware, cat. no. 31-501-630)
- Weights (Kern, cat. no. WB1010788)
- Evaporator, Hei-VAP Advantage (Heidolph, serial no. 200362253)
- Vacuum pump (Labotal; MZ 2C NT, serial no. 104539206)
- Digital hotplate stirrer, 'witeg' WiseStir, SMHS systematic multi-hotplate stirrers, 6- places, ceramiccoated plates, independent heating and stirring control, back light LCD, up to 350 °C, 80–1,500 rpm; stirring magnet(s): PTFE (Witeg Labortechnik, item no. DH.WMH03506)
- Precision Balance (Precisa, cat. no. LX-220A)

Test, printing and other equipment

- Dispensing system with piezoelectric nozzle (Scienion, model sciFLEXARRAYER S3)
- Vacuum oven, ThermoStable OV (WOV) series (Daihan Scientific, cat. no. 2268)
- Multimeter/data acquisition/switch system, Keithley model 2701 multifunction switch (Tektronix)
- Transmission electron microscope, Tecnai T12G2 (FEI, model Tecnai G2 T20 S-Twin)
- Respirator mask with filter (Scott Safety, cat. no. A1B1E1K1-P2/P3)
- Vacuum pump (Edwards, cat. no. XDS5 A72501903)

NATURE PROTOCOLS

PROTOCOL

- Stainless steel chamber (home-made, Technion) with a volume of 100 cm³
- Computerized calibration system (Umwelttechnik MCZ, Germany), model CGM 2000 (serial no. 1101-011)
- Nitrogen generator, model M-30 (On Site Gas)

Software

- CleWin
- LabVIEW National Instruments
- MATLAB

Procedure

Electrode array microfabrication in clean room conditions Timing 6-8 h (depends on number of wafers)

▲ CRITICAL Steps 1–25 must be performed in a clean room facility (for this work, a class 1,000 (ISO 6) with a class 100 (ISO 5) work area was used). Steps 1–14 were performed for nine wafers (4 in), each of which consist of 21 devices of eight sensors. This is maximum batch capacity for the Evatec BAK-501 evaporation system.

1 Clean the silicon wafer in an acetone bath with sonication for 5 min. Rinse the wafer with clean acetone, methanol and then isopropanol. Dry it by spinning at 3,500 rpm for 1 min. Inspect the wafer by optical microscope.

▲ CRITICAL STEP If the storage conditions of the wafers are unknown or questionable, this cleaning step is necessary. If you know that the silicon wafer is clean, you can start the process without any precleaning.

- 2 Bake the wafer on a hot plate at 290 ± 10 °C for 5 min for dehydration and vaporization of any solvents, and then let the wafer cool to RT for 5 min.
- 3 Place the wafer in the center of the supporting chuck of the spin coater, and make sure that it sticks by applying a vacuum. Set the spinner parameters to 5,000 rpm for 1 min, with an acceleration of 10 m/s². Dispense 2 ml of photoresist AZ-5214 on the center of the wafer and spin immediately. Note: any other negative resist that is suitable for lift-off processes could be used. ? TROUBLESHOOTING
- 4 Prebake the photoresist on a hot plate at 110 °C for 1 min.
- 5 Clean the mask with the electrode array patterns (for the design of photolithography mask, see Supplementary Data 1 and Supplementary Software) in N-methyl-2-pyrrolidone and then in hot PRS-2000 solution (70 °C) during 10 min, wash with DDW water for 1–2 min. Dry the mask at 2,000 rpm for 1 min.
- 6 Load the mask and the silicon wafer into the mask aligner. Expose the wafer under i-line UV light at 365 nm and at an intensity of 14.5 mW/cm² for 1.5 s to form the electrode array patterns. Note: the exact conditions will depend on the equipment used, the thickness of the photoresist and its thermal history. Use the MicroChemicals datasheets as a guideline.
- 7 Place the wafer on a hot plate for a postexposure bake at 120 °C for 1 min.
- 8 Expose the wafer at an intensity of 14 mW/cm^2 for 9 s, without using a mask.
- 9 Develop the photoresist for 30 s using 10% (vol/vol) TMAH developer, and then wash it in DDW for 1–2 min. Dry the wafer by spinning at 3,500 rpm for 1 min.

CRITICAL STEP Check the thickness of the photoresist by profilometry. It should be >1.2 μ m so that the lift-off process that follows will be effortless. Metal deposition by the lift-off method is recommended.

- 10 Check the wafer under the microscope to verify whether the patterns have developed properly.
 ▲ CRITICAL STEP Check the patterns with an optical microscope. If the resist is not completely removed from the exposed areas, place the wafer back into the developer and apply further development in steps of 10 s, after which you should rinse, dry and check it again with the microscope until full development.
 ? TROUBLESHOOTING
- 11 Use oxygen plasma descumming system for surface treatment before metal evaporation for better metal adhesion. Place the wafer in the chamber of plasma system for 1 min. Keep the pressure at 200 mTorr and the power at 100 W.

▲ **CRITICAL STEP** If the chamber is not cleaned before etching the wafer, unwanted substances (depending on the previous etching process) can be deposited on the wafer surface, making it unusable.

12 Load the wafer into the evaporator system face down, and activate the pump. Wait until the vacuum is at least as low as 2×10^{-7} Torr. Set the parameters for metal evaporation. The thickness of first layer (titanium) is 20 nm, and the evaporation rate is 2 Å/s. The thickness of the second layer (platinum) is 130 nm, and the evaporation rate 4 Å/s. Start the evaporation. Check the rate and temperature during the evaporation.

CRITICAL STEP The metal deposition should be performed by E-beam evaporation system under high vacuum $(4 \times 10^{-7} \text{ Torr or less})$.

? TROUBLESHOOTING

13 Soak the wafer in a beaker with acetone and sonicate it for 2–5 min for the metal lift-off process. Rinse it with clear acetone, methanol and isopropanol. Inspect the wafer with electrode arrays under an optical microscope. If it is clean, wash it with DDW and dry; otherwise, repeat the sonication with acetone.

▲ CRITICAL STEP Keep the wafer wet between the rinsing and during inspection under the microscope.

? TROUBLESHOOTING

14 Inspect the electrode array and contact pads for defects under an optical microscope.

Microbarrier (ring) fabrication Timing 2 h for three wafers

Figure 3a shows a schematic flow diagram of microbarrier fabrication (Steps 15-24).

- 15 Heat the wafer on a hot plate at 120 °C for 5 min for dehydration and solvent vaporization. Then, let the wafer cool down to RT for 2 min.
- 16 Place the wafer in the center of the spinner chuck, making sure it sticks by applying vacuum. Dispense 2 ml SU-8 2002 at the center of the wafer, and run the following spin-coating program: spin the wafer at 500 rpm with acceleration of 50 rpm/s for 10 s to allow the resist to spread, ramp the speed up to 2,000 rpm with acceleration 200 rpm/s, hold it for 30 s and then ramp it down.
- 17 Bake the photoresist on a hot plate at 95 °C for 2 min.
- 18 Clean the mask for microbarrier patterns (for the design of the mask, see Supplementary Software and Supplementary Data 1) in NMP and then in hot PRS solution (700 °C) for 10–15 min, wash it with DDW for 1–2 min and dry the mask at 2,000 rpm for 1 min.
- 19 Load the clean mask on a mask holder of a mask aligner (Karl Suss MA6). Place the wafer on a holder of the mask aligner, then expose the wafer to an intensity of 14 mW/cm² for 6 s (84 mJ/cm²).
- 20 Develop the photoresist for 1 min using PGMEA developer, then rinse and wash it with IPA.
- 21 Place the wafer on a spinner, and dry it by spinning at 5,000 rpm for 60 s.
- 22 Use an optical microscope to inspect the cleanliness of the substrate after SU-8 development. ▲ CRITICAL STEP The surface of the electrodes and anything between them must be completely clean.

? TROUBLESHOOTING

- 23 Measure the height of the SU-8 microbarrier by alpha step.
- 24 Cure the SU-8 patterns on a hot plate by the following program: start on a cool plate (22 °C), then heat up to 150 °C, and hold it for 15 min.

Dicing Timing 2 h (for three wafers)

- 25 Protect the wafer by coating it with photoresist AZ-4533. Put the wafer in the center of the spinner. Activate the vacuum of spinner. Set the spinner parameters to 5,000 rpm for 1 min with an acceleration rate of 10 m/s^2 . Dispense 2 ml photoresist AZ-4233, and spin it. Bake the wafer at 110 °C on a hot plate for 1 min.
- 26 Attach the dicing tape on a dicing frame (80 μ m). Place the wafer at the middle of the frame, and put the frame on the dicing holder.
- 27 The dicing is executed by dicer machine DAD 3350. Set the typical recipe, and enter the correct parameters required for dicing (Supplementary Manual 1).
 - Channel 1 = 15.0 mm
 - Channel 2 = 15.3 mm
 - Align the wafer
 - Check the number of lines for cutting
 - Choose the dicing direction, then start cutting
 - Turn the wafer to 90°, and resume the cutting

- 28 Rinse the wafer in acetone, methanol and IPA using only sprayer. The wafer remains on blue tape for this washing step. Then, dry it on a spinner or with pressurized hydrogen.
 ▲ CRITICAL STEP Confirm that the wafer is clean using an optical microscope.
- 29 Store the devices on tape in a vacuum desiccator.

Synthesis of 2-ethylhexanethiol-capped gold nanoparticles Timing 30 h (Extended Data Fig. 8 and Supplementary Data 3)

- 30 Activate the digital stirrer to 800 rpm. Place an iced water bath on the stirrer plate. ▲ CRITICAL STEP Using thermometer, check the bath temperature (should be at 4 °C). The roundbottom flask will be kept under these conditions during the synthesis.
- 31 Gold salt solution preparation. Dissolve 3.1 mg $HAuCl_4 \times H_2O$ in 25 ml DDW. $HAuCl_4 \times H_2O$ should be transformed to a glass vial using a plastic or Teflon spatula. Then, 25 ml of DDW should be measured using a volume-measuring funnel. Mix the $HAuCl_4 \times H_2O$ in DDW by shaking the vial. The color of the solution should be transparent yellow.
- 32 *Tetraoctylammonium bromide (TOAB) solution preparation.* Dissolve 0.15 g TOAB in 80 ml toluene. Toluene is measured with a volume-measuring funnel. Then, transfer to a round-bottom flask of 500 ml volume. TOAB is measured on weighing paper and transferred directly into the toluene solvent in the round-bottom flask. Add a stirring bar. Stir the mixture for 10 min at RT and 800 rpm; the solution should be transparent.
- 33 *Transfer of gold salt to toluene.* Transfer AuCl₄ (Step 31) from aqueous HAuCl₄ × H₂O solution (Step 32) to a toluene solution by the phase-transfer reagent TOAB. Mix both solutions in a separating funnel. After separation, the organic phase is on the top and is brown in color. The aqueous phase on the bottom should be transparent. Discard the aqueous phase, and use the organic phase for the next step.
- 34 Transfer the content of HAuCl₄ with TOAB in toluene into a round-bottom flask (at 4 °C), and stir it vigorously at 800 rpm with a magnetic stirring plate and stirrer. Then, add 15.2 μl of 2-ethlhexanethiol using a digital pipette by fast injection.

! CAUTION Handle the 2-ethlhexanethiol under a chemical hood. Keep the pipette and the gloves in the hood for a few hours.

- 35 *Reducing agent preparation.* Measure 25 ml of DDW using a volume-measuring funnel. Transfer DDW to a vial, and cool it with ice for 10 min. Then, dissolve 380 mg (in a glass vial) of $NaBH_4$ (0.4 M) using the cooled water. Mix the solution by shaking. Use this solution immediately after mixing.
- 36 Nucleation and growth of gold NPs. Add ice-cold NaBH₄ solution from Step 35 into the HAuCl₄-TOAB in toluene solution (Step 34) at 4 °C, 800 rpm of magnetic stirring plate.
 ! CAUTION NaBH4 is a very strong reducing agent. It requires safety equipment such as gloves and safety googles.
- 37 Leave the reaction to stir at 800 rpm at 4 °C for at least 3 h. Extended Data Fig. 9 shows the general reducing reaction for gold reagent using a stirring system for degrees including stabilizer and reducing reagent.

▲ **CRITICAL STEP** It is important to maintain the same temperature and stirring rate during synthesis by mixing ice and water in the reaction bath.

- 38 A purification step of the MCGNP solution starts with separating the water and organic phases by using a separating funnel. The organic phase is the upper dark-brown phase, and the lower transparent phase is water. Drain the water phase, and discard it.
- 39 Transfer the organic phase from the separating funnel (containing the gold nanoparticles) to a round flask of 500 ml.
- 40 Connect the flask to a rotary evaporator according to the instructions (bath at 40 °C, rotating speed 140–170 rpm). Usually, it takes ~15–20 min to evaporate the entire 80 ml toluene. At the end of the procedure, there should be no solvent and only nanoparticle residuals.
- 41 Separate the flask from of the evaporator according to the instrument instructions.
- 42 Put 1 ml toluene in the flask, and mix until all the MCGNPs are in solution.
- 43 Add 400 ml ethanol, and store it for overnight (18–20 h) to slowly precipitate the nanoparticles out of toluene.

? TROUBLESHOOTING

44 Transfer all the liquid content into centrifuge bottles. Centrifuge for 10 min at 3,000 rpm. At the end, a nanoparticle (NP) pellet should be stuck to the walls of the bottles.

- 45 Discard the solvent. After the NPs are dry on the walls of the bottles, dissolve them again in toluene.
- 46 Take a small round flask (25 ml), weigh it and record its weight as 'A gram'.
- 47 Put the NP solution in toluene.
- 48 Use a rotary evaporator as described above.
- 49 Weigh the flask again after the solvent has evaporated, and record its weight as 'B gram'.
- 50 Calculate how much solvent you need to add to reach the desired concentration of toluene to add $((B A) \times 1,000)/5)$. After dissolving, transfer the solution to a new glass vial and seal with parafilm.

▲ CRITICAL STEP Store all NP solutions at 4–6 °C in glass vials.

51 Inspect the MCGNP solutions by TEM to examine the shape, diameter and size distribution of the MCGNPs, as well as the purity of the solution. Figure 3, e.g., shows MCGNPs with organic modification of dodecanethiol and MCGNPs with 2-ethylhexanethiol modification.

Deposition of MCGNP solution by inkjet printing Timing 1 h

▲ **CRITICAL** The inkjet printing of MCGNP solution uses the Scienton dispenser system (Supplementary Manual 2).

!CAUTION Using the toluene solution requires an air exhaust and respirator mask, with filter A1B1E1K1-P2/P3. The dispenser system must be under hood conditions.

52 Power on the SciFlex_s3 program, dry air insertion and vacuum pump. Set the inside humidity control at 40%.

▲ CRITICAL Steps 60–68 must be performed under controlled humidity and temperature.

- 53 Place the the PDC 70 (Piezo Dispenser Capillary nozzle) without connecting it to the manifold.
- 54 *Prime by washing with water.* Connect the flush bottle to the manifold. Work according to the printer instruction. At the end of washing, disconnect the flush bottle. Connect the pressure differential changeover (PDC) to the manifold after verifying the initial drop existence. Continue prime washing.
- 55 Prime by washing with toluene. Repeat Step 54 with toluene.
- 56 *Set up the nozzle.* Move the nozzle to the camera station; set its position to the center, and focus it on the front of the camera; activate the dispense mode; set up a droplet through control of the following parameters: voltage, pulse and frequency; set nozzle parameters; check the droplet volume.

? TROUBLESHOOTING

- 57 Load 60 µl MCGNP solution into the selected well in the 384-well plate, using a digital pipette.
- 58 Aspirate 15 μl of the 2-ethylhexanethiol-capped gold nanoparticle solution using the nozzle (PDC 70).
- 59 Check and optimize the droplet volume of gold nanoparticle solution by repeating Step 56. The drop volume must be 300-350 pL.
- 60 *Set up the target.* Go to 'Robot setup'. Define the target position in a sheet Target substrate. Calibrate the *XYZ* position by moving the nozzle tip carefully to the right point. The *XY* spot area for the designed chip is 75,000. Spot-area no. *X* is 5 with the offset 15,300. Spot-area no. *Y* is 5 with the offset 15,000. Note: all dimensions are in μm.
- 61 Define the pattern parameters: start point, field size in the x and y direction, number of fields and dot pitch (the distance between the spots). Set up the number of fields as x = 1, y = 1 for easier system operation.
- 62 Calculate the number of drops by formula $DN = RV \times 1,000/DV$ (DN is the number of drops, RV is the required MCGNP solution volume in nl, DV is the drop volume in pl). RV = 30 nl for 2-ethlhexanethiol-capped gold nanoparticles. RV = 40 nl for dodecanethiol-capped gold nanoparticles.
- 63 Go to field setup and insert the number of drops calculated in Step 62.
- 64 Select the active well by clicking on it (the selected well turns red). Choose the field by clicking on it (the chosen field turns to light green).
- 65 Check all the selected parameters in the main window: Probe, Run and Target program.
- 66 Start run for the printing activation.
- 67 Check the printed devices with the upper camera.

▲ **CRITICAL STEP** Verify if the morphology of the printed devices is as expected according to their chemistry. The devices with splitting drops around the electrodes should be excluded.



Fig. 9 | The sensing features of the MCGNP-based sensing response.

MCGNP stabilization — Timing maximum 48 h for 2-ethylhexanethiol (72 h for dodecanethiol)

- 68 Put the printed wafer into a vacuum oven (T = 55 °C, P = 75 cmHg) immediately after printing. **CRITICAL STEP** The drying time of MCGNPs on the sensor surface depends on the type of ligands. The drying time for dodecanethiol and 2-ethylhexanethiol modifications are 48 h and 22 h, respectively (Box 1).
- 69 Separate the devices from the dicing tape, and put them on trays with names. ▲ CRITICAL STEP Store the device trays in a vacuum desiccator.

Measuring the sensors' response Timing 2 h (eight devices in one chamber)

- ▲ CRITICAL The setup for the sensors response examination is shown in Supplementary Data 2.
- 70 Calculate the permeation rate, molar constant and temperature for the selected concentration range (Supplementary Manual 3).
- 71 Set the permeation oven at the calculated temperature to reach the specific concentrations. Note: for n-octane at four concentrations—0, 41.5, 84.2 and 134.5 ppm—set the temperature at 110 °C.
- 72 Half-fill the diffusion 5 mm tubes with the desired VOC solution, and heat them to the selected temperature.

▲ CRITICAL STEP It is important that the tubes be heated to the correct temperature before progressing. Allow at least 1 h for this step.

- 73 Insert the diffusion tubes into the ovens after stabilization of the required temperature.
- 74 Insert the devices into the printed circuit boards (Supplementary Data 2).
- 75 Connect the boards to the exposure chamber, and close the system to seal the chamber. The VOC inlet valve should be set as closed and the vacuum valve set as open.
- 76 Apply a pressure of at least 200 mTorr inside the exposure chamber to be sure that the baseline does not change.
- 77 Start the LabVIEW program to measure the response of the devices. The measurement exposure comprises three cycles; each cycle is 5 min of vacuum and 5 min of exposure of the VOC at increasing concentrations (Fig. 5a).

Analysis of the sensors' response Timing variable

- 78 The output of the measured resistance data is received in a csv file. The baseline resistance, R_{b} , is resistance before any gas exposure. The sensing starts when the resistance changes during espouse to gases at the stabilization stage. The difference in these resistances is called ΔR_{end} .
- 79 Use MATLAB program or other software to extract the features. Use the program to calculate the ΔR_{end} feature (Fig. 9). Calculate average and standard deviation of ΔR_{end} for each device. Calculate the VI, which is the average response divided by the standard deviation, according to

$$VI = AVG\left(\frac{STDEV\frac{\Delta R}{R_{End}}}{AVG\frac{\Delta R}{R_{End}}}\right)$$

- 80 A low VI indicates small distributions between the measured sensors. Use the MATLAB program to extract the normalized response to different VOC concentrations.
- 81 Check the normalized response of the devices; it should have dose dependency with regard to the VOC concentration.

? TROUBLESHOOTING

Troubleshooting

Troubleshooting advice can be found in Table 1.

Table 1 | Troubleshooting table

Step	Problem	Possible reason	Solution
3	The wafer is not uniformly covered with the resist	Not enough resist was used for the spin-coating The wafer was not clean. There is a defect or contamination on the wafer surface	Remove the resist layer by washing the wafer in hot NMP solution 5 min, then 5 min in PRS solution. Wash it with water, and repeat the spin-coating procedure (Steps 1–3)
9	The patterns are inhomogeneous. There is still some unwanted resist left, especially in sharp corners	The exposure intensity was too low The wafer was not developed for long enough	Repeat the development procedure for 10 s (Step 9). If it does not work and the resist is still left, clean the wafer by washing in hot NMP solution for 5 min, then 5 min in PRS solution. Wash it with water and repeat the spin-coating, photolithography and developing procedures (Steps 4-9)
12	Weak adhesion of metal to the substrate	Oxygen plasma treatment was insufficient	Discard the wafer, and start a new process from Step 1
13	Small metal parts and particles from lift-off attach on the SiO_2 substrate	The wafer was dried during the lift-off process	Sonicate the wafer in acetone for 5 min, then rinse with clear acetone, methanol and isopropanol
22	Part of SU-8 remained on the substrate	The wafer was not developed long enough	Repeat the development procedure only for 5-10 s (Steps 20-21)
	Part of SU-8 patterns detached from the surface	Overdeveloping	Clean the wafer with acetone, methanol and isopropanol. Repeat the spin-coating, photolithography and developing procedures (Steps 15-22)
43	MCGNPs do not dissolve in ethanol	Ethanol does not precipitate the NPs	Try to precipitate with methanol
56	The droplet is not one unit and divided into several droplets	The nozzle piezoelectric parameters for toluene are not the same as water	Change the following parameters: voltage, pulse and frequency until receiving one drop
81	The response is noisy, with high resistance	The solvent did not totally evaporate, or the MCGNP solution is no good	Put the device in the vacuum oven for longer. If the resistance does not decrease, try another synthesis solution

Timing

Steps 1–14, electrode array microfabrication in clean room conditions: 8 h Steps 15–24, microbarrier (ring) fabrication: 2 h Steps 25–29, dicing: 2 h Steps 30–51, synthesis of dodecanethiol-capped gold nanoparticles: 30 h Steps 52–67, MCGNP solution deposition by inkjet printing: 1 h Steps 68 and 69, MCGNP stabilization: 48 h Steps 70–77, measuring the sensors' response: 2 h Steps 78–81, analysis of the sensors' response: variable

Anticipated results

If you perform the synthesis of the MCGNPs as described in Figs. 1 and 8 and Extended Data Fig. 8, you can expect results similar to those shown in Extended Data Fig. 1. If you deposit the MCGNP solution on interdigitated electrodes without microbarrier, you can expect results similar to those in Extended Data Fig. 2. If you get 'coffee rings' and/or irreproducible electrical or chemical sensing properties, then you should restart the deposition of the MCGNPs in a confining ring-like structure, as shown in Fig. 3. In this case, you should expect results as shown in Figs. 4–6 and Extended Data Figs. 5–7. If you try to connect an array of MCGNP-based sensors with pattern recognition methods, then you can expect to analyze complex profiles or gaseous mixtures similar to those in Figs. 7, 8.

Data availability

The data supporting the findings of this study are available within the article, its Supplementary Information and Source Data files and the primary supporting research papers.

Code availability

The software used in this protocol is provided as Supplementary Information.

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Author contributions

Y.M. and M.A. designed, fabricated and characterized the MCGNP-based sensors; V.K. synthesized and characterized the MCGNP solutions; E.M. characterized the sensors; Y.Y.B. provided and analyzed the clinical studies; G.S. and H.H. designed the concept and carried out the R&D process. All authors participated in writing the manuscript.

Competing interests

The authors declare no competing interests.

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Correspondence and requests for materials should be addressed to H.H.

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Extended Data Fig. 1 | a-d, TEM characterization of gold nanoparticles with different organic ligands: dodecanethiol (**a**); 2-ethylhexanethiol (**b**); analysis of core size distribution of dodecanethiol (**c**); analysis of core size distribution of 2-ethylhexanethiol (**d**).



SiO₂ + 0.3µm GNP

SiO₂ + 2.5µm GNP

0.3µm

Extended Data Fig. 2 Topology characterization after printing 20±0.3 nl MCGNP solutions. a, b, Optical microscopic images of 8-sensor chips
made of dodecanethiol-capped (a) and 2-ethylhexanethiol-capped (b) gold nanoparticle films. The different morphologies appearing in a and b could
be related to the application of different chemistries, which, in turn, lead to different surface tensions and evaporation process of the solvent.
c, Magnification of the dodecanethiol-capped gold nanoparticle sensor around the coffee ring shape. d, XPS elemental surface analysis of
dodecanethiol-caped gold nanoparticles on SiO ₂ surface, as a representative example (Supplementary Fig. 16).

20.83

3.72

63.22

85.65

8.73

1.31

5.07

6.34

1.91

2.98

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Extended Data Fig. 3 | a-c, Contact angle measurements by optical goniometery of: SU-8 without oxygen plasma (**a**); SU-8 with oxygen plasma (**b**); and SiO₂ surface (**c**). Higher contact angle indicates higher hydrophobicity of the surface, which, in turn, better allows to hold the drops inside the barrier.

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Extended Data Fig. 4 | a-d, SEM images of SiO₂ barrier after lift-off process (a,b); and SU-8 2002 barrier made by photolithography process (c,d).

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Drop casting type	Scheme	Microscopic picture	Morphology
Drop casting on a surface without a micro-barrier		0	Coffee rings and spillover
Drop casting less then micro- barrier height			Coffee rings
Drop casting more than micro- barrier height			Coffee rings
Drop casting flat with micro- barrier height			No coffee rings

Extended Data Fig. 5 | Schematic description of the droplets behavior and effect of the microbarrier height on the evaporation of MCGNP solution droplet.



Extended Data Fig. 6 | Relationship between the microbarrier height and printed MCGNP solution. a,b, Values of VI (**a**) and amplitude (**b**) of response to decane as a function of deposited volume of ethylhexanethiol-capped gold nanoparticle solution. **c**,**d**, Values of VI (**c**) and amplitude (**d**) of response to decane as a function of deposited volume of dodecanethiol-capped gold nanoparticle solution. Note: the VI is a relative measure of the variance of the response, and the amplitude is a measure of its level. For optimized devices, one has to look for the lowest possible VI while keeping the amplitude of the sensing response as high as possible.



Extended Data Fig. 7 | Boxplot of the extracted feature of 24 dodecanethiol-capped gold nanoparticle sensors for various storage conditions: vacuum, nitrogen and room air.



Extended Data Fig. 8 | Schematic depiction of the MCGNP synthesis process.



Extended Data Fig. 9 | Schematics of the reduction step during the MCGNP synthesis.